

Application Data Sheet**Applicant Information**

Applicant Authority type:: Inventor
Primary Citizenship Country:: Japan
Status:: Full Capacity
Given Name:: Ken
Family Name:: YOSHIZAWA
City of Residence:: Niigata
Country of Residence:: JAPAN

Correspondence Information

Correspondence Customer Number:: 25944

Application Information

Application Type:: National Phase
Subject Matter:: Utility
CD-ROM or CD-R:: None
Title:: A METHOD FOR PRODUCING A SILICON
WAFER AND A SILICON WAFER
Attorney Docket Number:: 126623
Suggested Drawing Figure::
Total Drawing Sheets:: 3
Small Entity:: No

Representative Information

James A. Oliff, Reg. No. 27,075 William P. Berridge, Reg. No. 30,024
Thomas J. Pardini, Reg. No. 30,411 Edward P. Walker, Reg. No. 31,450
Robert A. Miller, Reg. No. 32,771 Mario A. Costantino, Reg. No. 33,565
Kirk M. Hudson, Reg. No. 27,562

Domestic Priority Information			
Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application is a	National Stage of	PCT/JP2004/009921	7/12/04

Foreign Priority Information			
Country::	Application Number::	Filing Date::	Priority Claimed::
JAPAN	2003-278483	7/23/03	Yes
Assignee Information			
Assignee Name::		SHIN-ETSU HANDOTAI CO., LTD.	
Street of mailing address::		4-2, Marunouchi 1-chome,	
City of mailing address::		Chiyoda-ku,	
State or Province of mailing address::		Tokyo,	
Country of mailing address::		JAPAN	
Postal or Zip Code of mailing address::		100-0005	